

FIG. 1

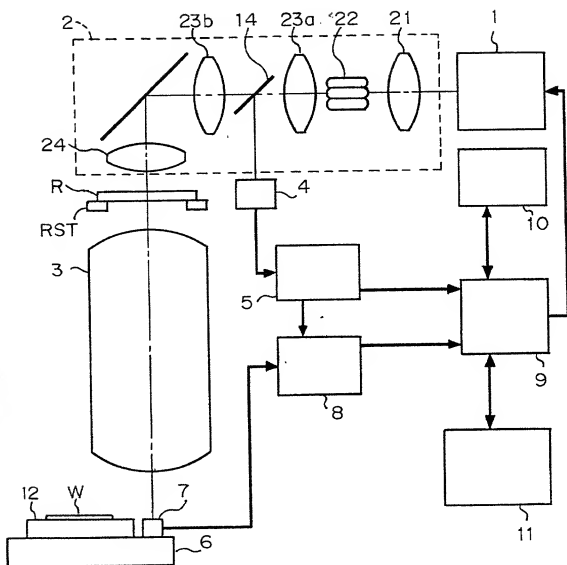


FIG. 2

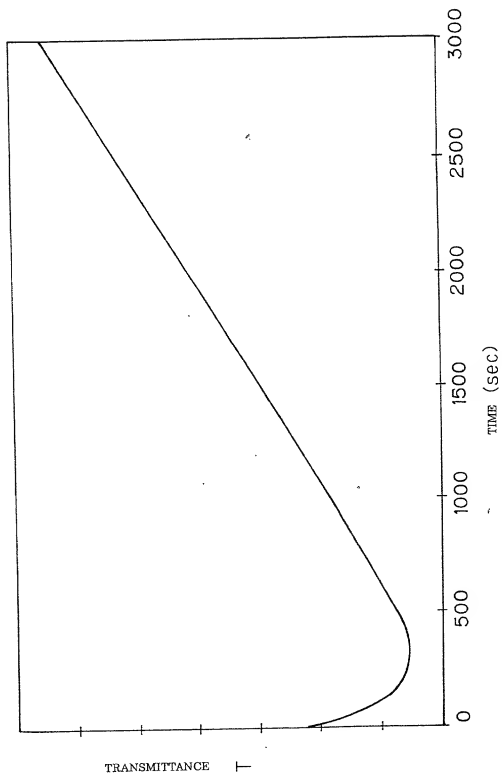
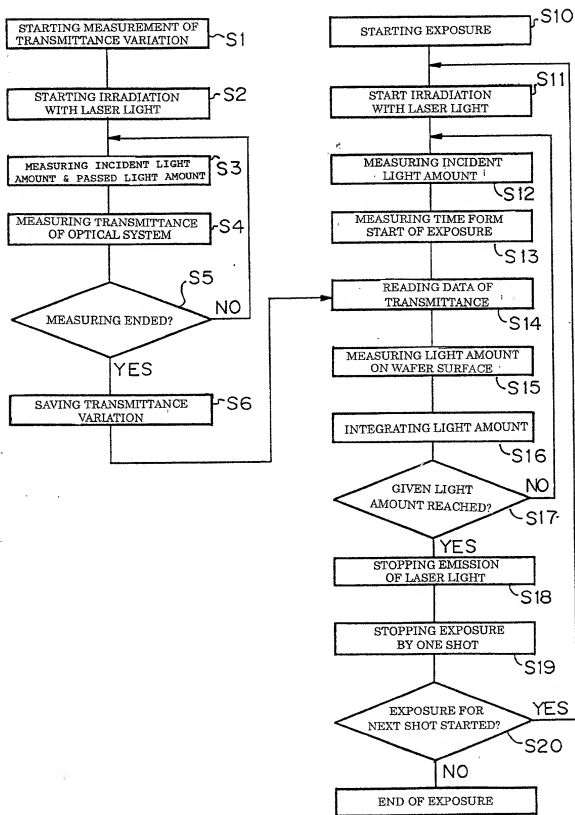


FIG. 3



[illegible]

FIG. 5

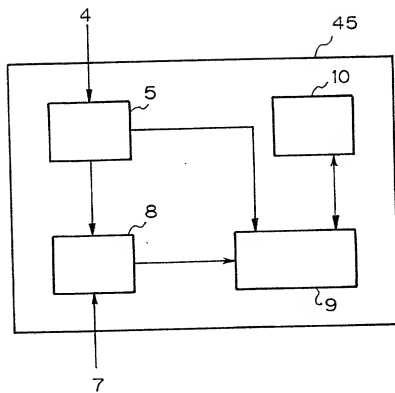


FIG. 6

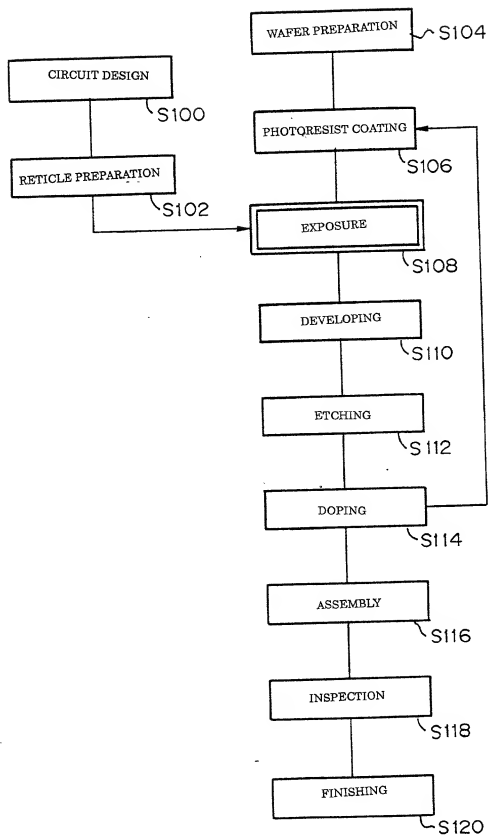


FIG. 7

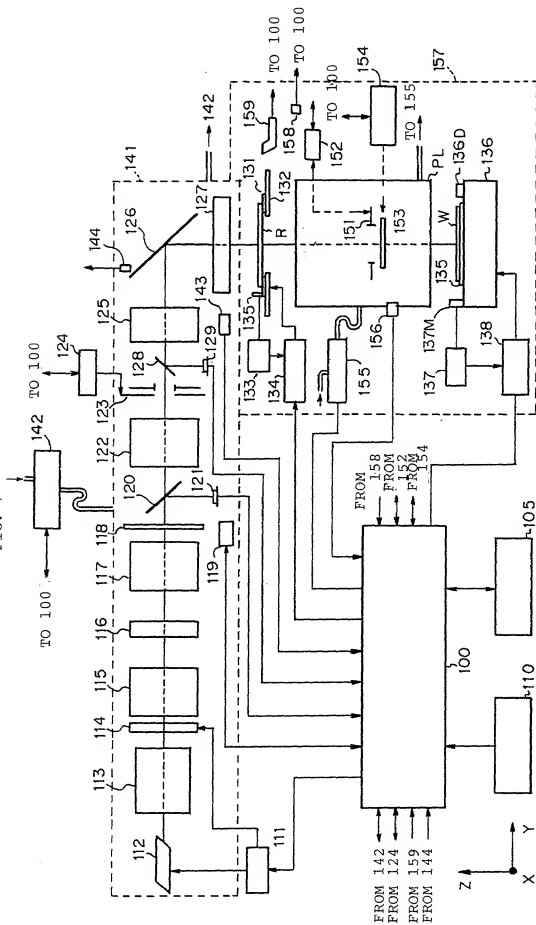


FIG. 8

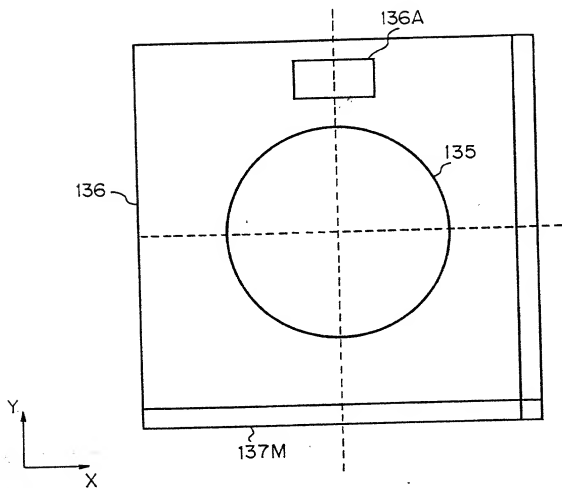


FIG. 9

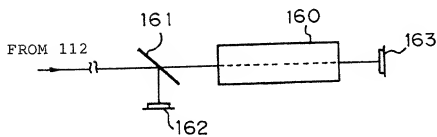






FIG. 11

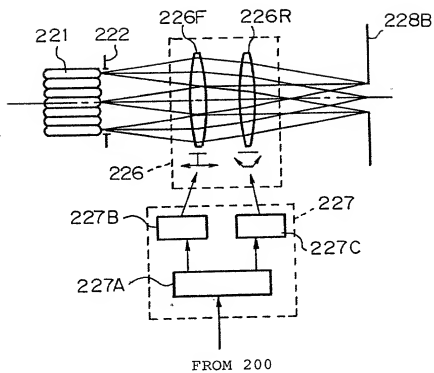


FIG. 12

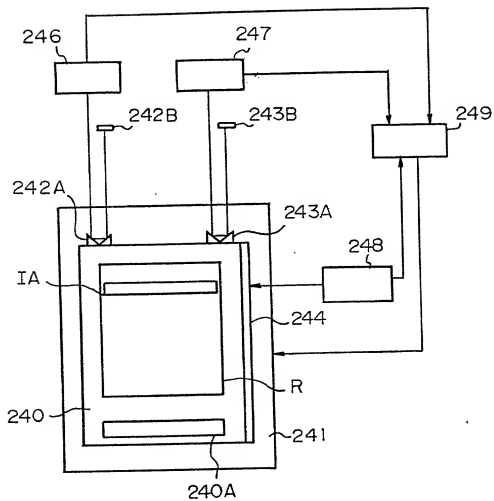
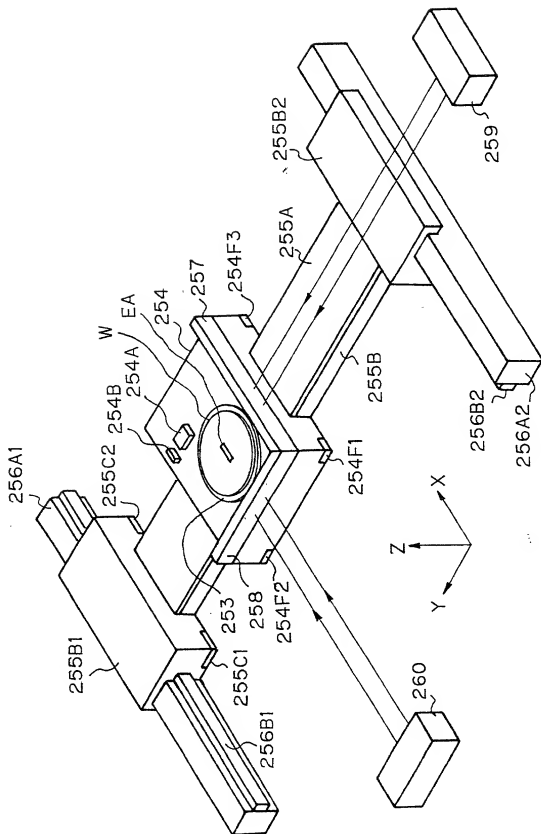


FIG. 13





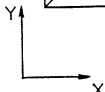
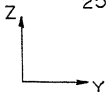
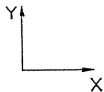
[illegible]

FIG. 16

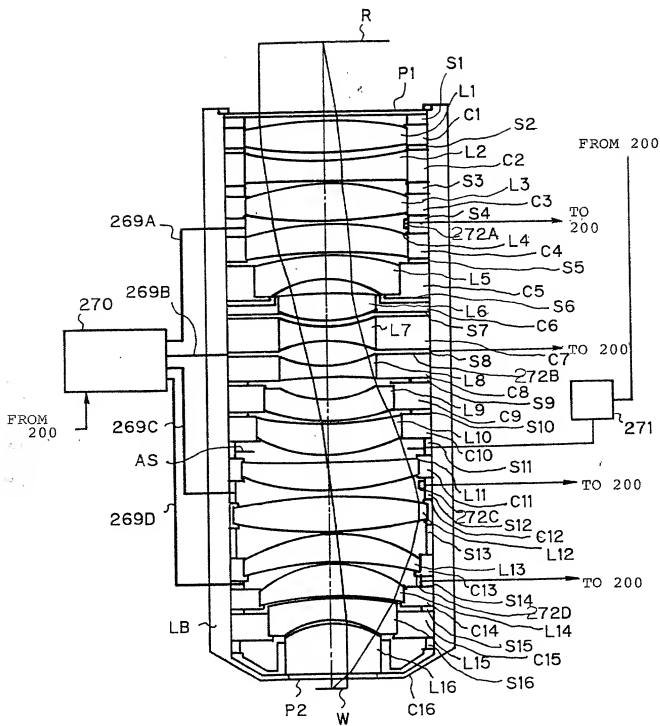


FIG. 17

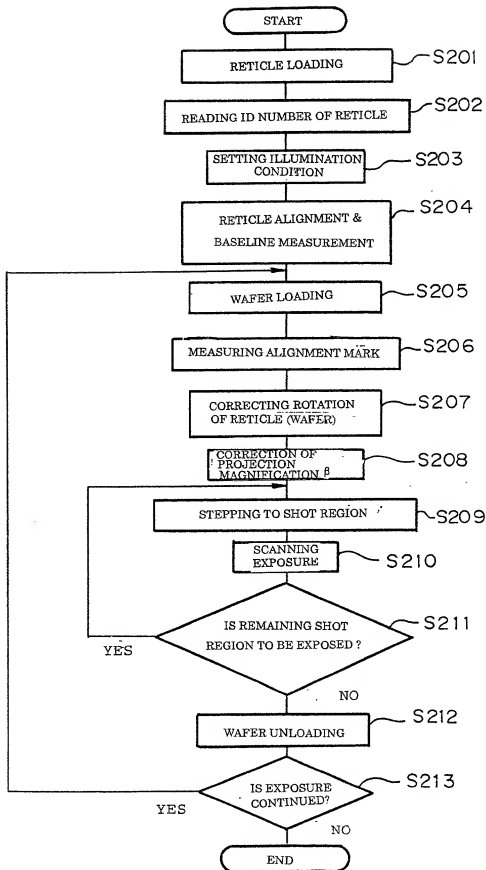
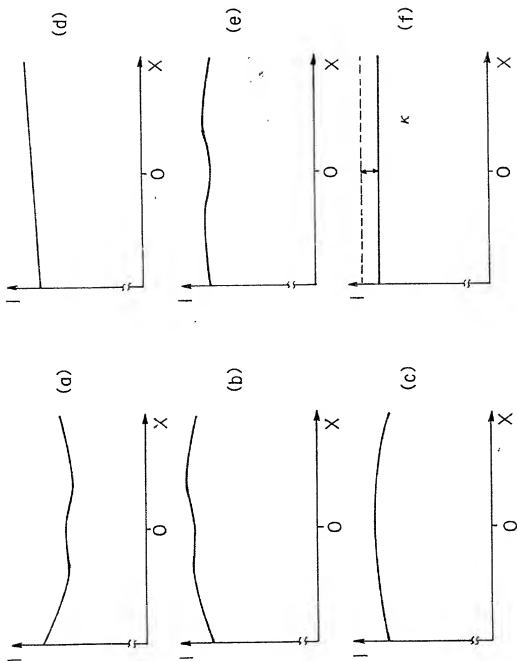




FIG. 18





[illegible]





FIG. 23

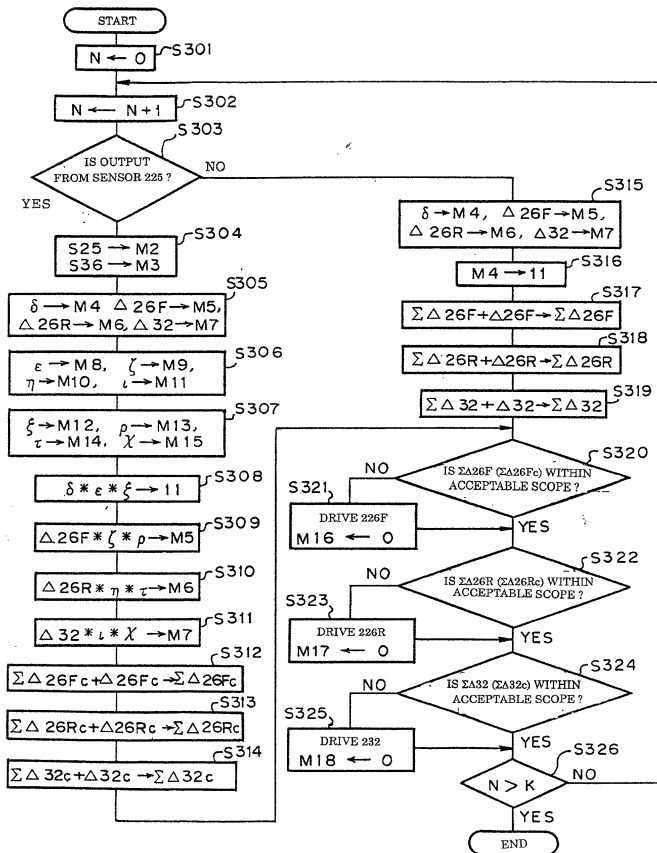


FIG. 24

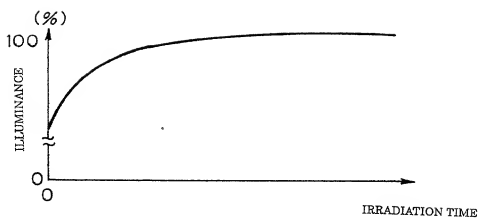
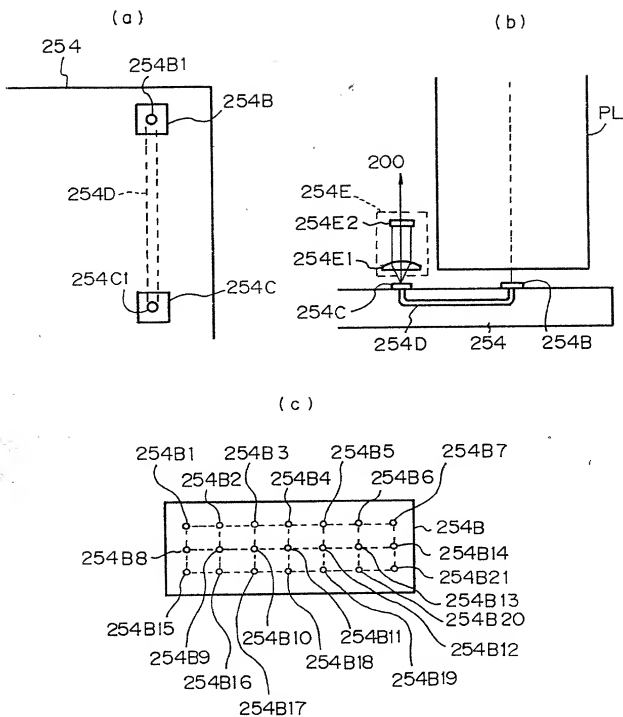


FIG. 25





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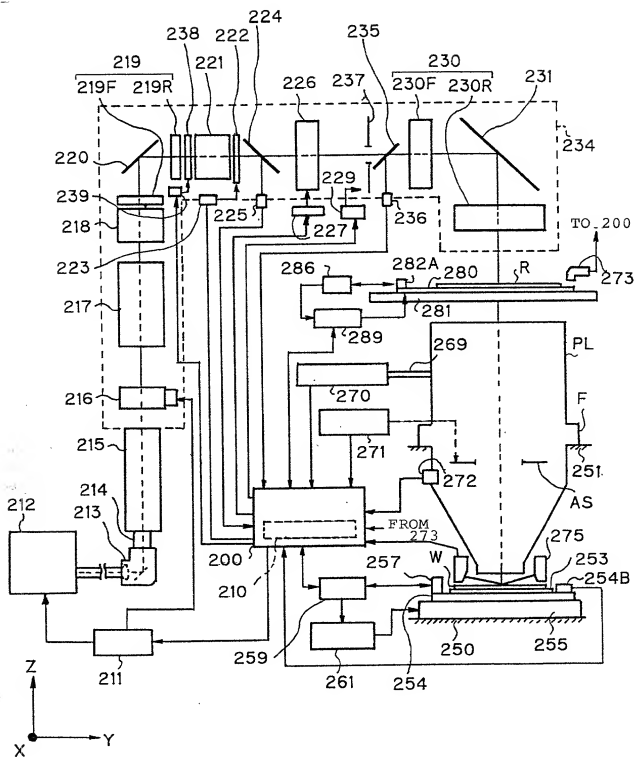


FIG. 27

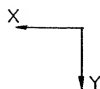
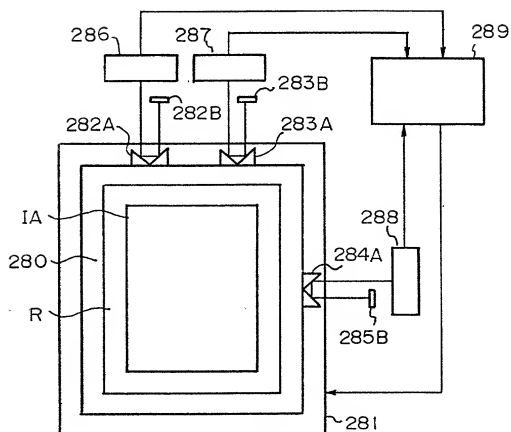


FIG. 28

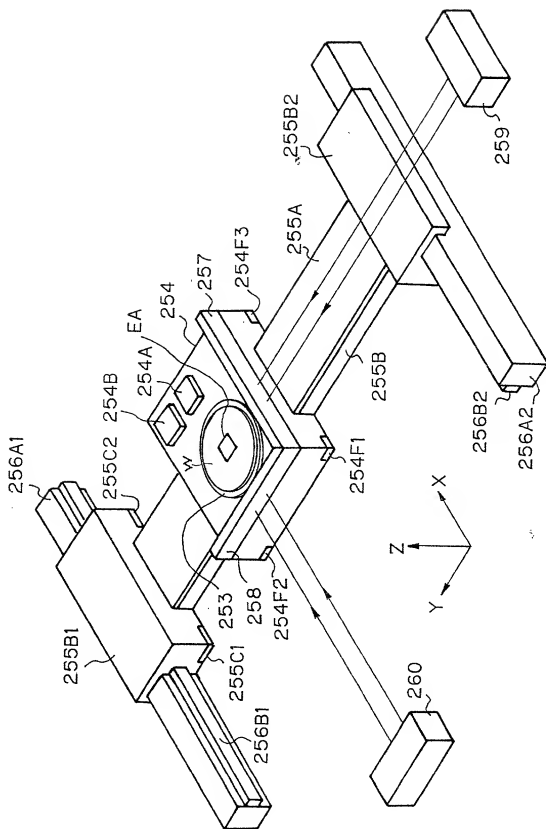
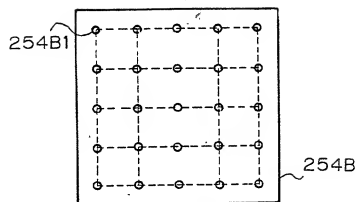


FIG. 29

(a)



(b)

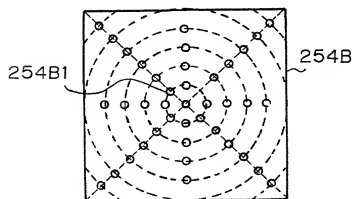


FIG. 30

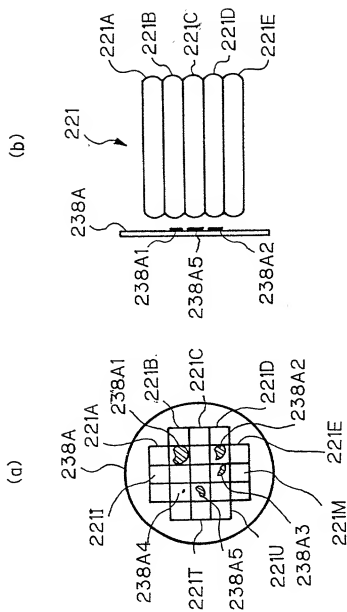
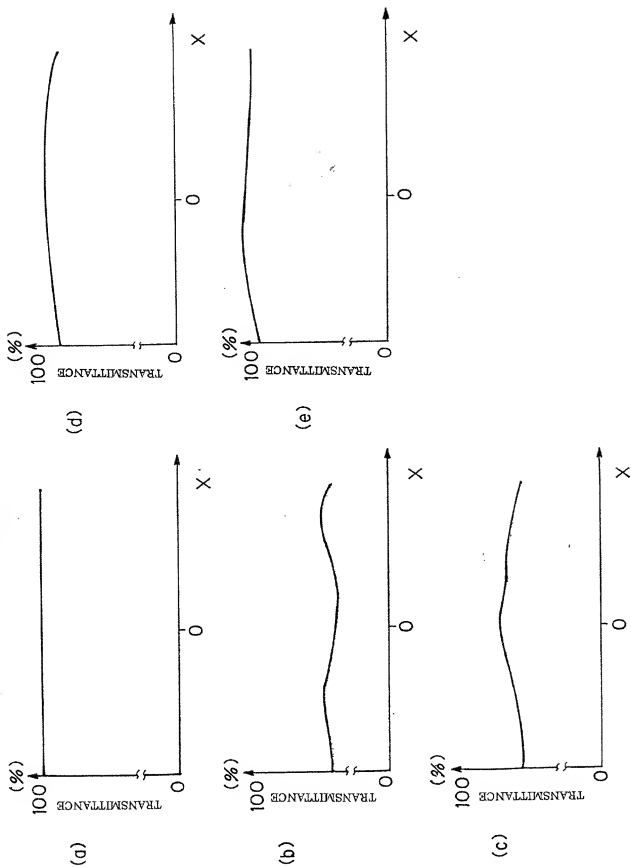


FIG. 31



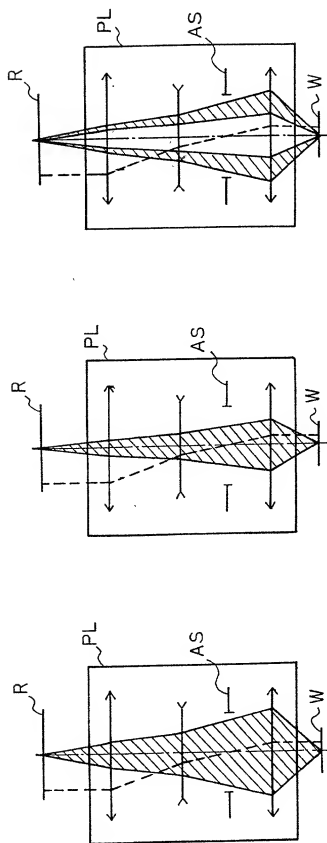


FIG. 32





FIG. 34

